247409US26 Docket No.

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF: Shosuke ENDOH, et al.

1716 10/751,898 GAU: SERIAL NO:

EXAMINER: MACARTHUR, S. FILED: January 7, 2004

PLASMA PROCESSING APPARATUS AND FOCUS RING FOR:

## REQUEST FOR EXTENSION OF TIME UNDER 37 C.F.R. 1.136

COMMISSIONER FOR PATENTS ALEXANDRIA, VIRGINIA 22313

SIR:

It is hereby requested that a three month extension of time be granted to May 27, 2010 for filing a response to the Official Action dated: November 27, 2009. responding to the requirements in the Notice of Allowability dated: filing the Formal Drawings. The Issue Fee due has been timely filed. responding to the Notice to File Missing Parts of Application dated: has been filed. filing a Notice of Appeal. A timely response to the final rejection, due filing an Appeal Brief. A Notice of Appeal was filed on: Applicant claims small entity status. See 37 CFR 1.27. The required fee of \$1,110.00 is being made by credit card payment online (if electronically filed), or is attached hereto (if paper filed), and any further charges may be made against the Attorney of Record's Deposit Account No. 15-0030.

Respectfully Submitted,

OBLON, SPIVAK, McCLELLAND, MAIER & NEUSTADT, L.L.P.

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